



Communications & Power Industries
 beverly microwave division

HEATWAVE

TECHNICAL DATA

VIL-409
1.3 GHz, 90 kW

**Scientific
 Microwave
 Amplifier System**

This data sheet supersedes any technical data sheet having a date prior to November 2009

DESCRIPTION

This integrated scientific microwave high power pulsed amplifier system uses a CPI-manufactured VKL-9130B IOT amplifier electron tube that is designed for scientific accelerator service. By using the high-efficiency, 1.3-GHz, 90 kW pulsed IOT in combination with modern solid state RF pre-amplifier, control and power-supply technology, CPI is able to furnish a compact, user-friendly, cost-effective high power scientific amplifier system.

The system's control center is an embedded microprocessor-based architecture which provides flexibility in selecting system operating parameters. Operation of the VIL-409 may be accomplished locally or remotely using a notebook computer or the accelerator system's controller via an Ethernet connection. Operation can be initiated (using default settings) by simply issuing an enable command and providing the RF signal that is to be amplified. Operational data is logged in the controller's on-board flash memory. The logged data may be uploaded to the external computer via the Ethernet connection for use in off-line troubleshooting or other purposes.

The high-voltage power supply (IOT Beam Supply) is a switching, capacitor charging type of supply with a relatively low-value smoothing/energy storage capacitor. A crowbar circuit is not required to divert stored energy during an internal IOT arc-event. System interlocks will remove the high voltage in less than 10 ms in the event of a normal-fault or less than 50 μS for faults requiring more rapid actions. Depending on the enclosure that is selected, cooling for the system is via a combination of both water and air or water only. The RF input power provided by the user is amplified more than 58 dB by a fully solid state RF power amplifier. The output of that amplifier provides the IOT's RF input power. The IOT gain exceeds 21 dB.



VIL-409

INSTRUMENTATION AND CONTROL

All operating, control, and data-collection functions are performed by the embedded controller. Critical interlocks, such as those required for system or personnel safety are hard-wired.

The control-center is a digital logic system that monitors and controls the performance of the high power microwave amplifier system. All system parameters, such as beam current, beam voltage, forward and reflected RF power and so on are displayed through a web-browser on the GUI (graphical user interface - monitor) of a remote computer via an Ethernet connection. Complete access to the status of each analog and digital input

and output is also remotely available to the user. Alternative control and monitor systems are also available via a software change in the embedded controller. Rather than a remote GUI, the embedded controller can also interface directly to the accelerator controller.

The embedded controller uses flash-memory to log the status of each of its inputs and outputs in a rolling file system that makes the last several days of operating available to the user. This data is stored in a format that will load directly into many spreadsheet programs (i.e., CSV format) for ease of data manipulation. These files may be e-mailed to CPI for assistance in troubleshooting and trend analysis should that be desired.

TECHNICAL CHARACTERISTICS

OUTPUT

Pulsed RF Power:	Adjustable to 90 kW, maximum peak power. Continuous control range in excess of 27 dB.
Operation	
Frequency:	1.3 GHz nominal. Electronically tunable over a 5.5 MHz bandwidth
Waveguide:	WR-650
Waveguide Arc Detector:	Standard. The IOT's output waveguide is protected by the control system, which will interrupt the RF drive power if arcs occur in the waveguide near the IOT.
Forward and Reflected:	A directional coupler at the klystron output is included. Excessive reflected power will also interrupt the RF drive power. A liquid-cooled, waveguide circulator capable of dissipating the energy reflected by a 4:1 VSWR is included..
Power Monitor	

INPUT POWER

Voltage:	400Y230 volt, 5-wire (wire per phase, neutral wire plus ground), 50/60 Hz. Other voltages available.
Line Current:	Approximately 30 Amp per phase at 90 kW peak output power, 3.2% duty.

COOLING

For the standard laboratory rack-mount enclosure option, clean water from an external source capable of 30 GPM at 60 PSIG, 10 to 40 degrees Centigrade. Laboratory air is also force-circulated through the enclosure.

In the NEMA 4X enclosure option, cooling is via water only with 35 GPM being required at 60 PSIG.

SIZE AND WEIGHT

Weight:	Approximately 1,500 pounds
Approximate Dimensions:	80 wide X 80 high X 40 deep
(maximum in inches)	
Other Features:	The unit also has lifting eyes on the top surface for pick-up via an overhead crane.is easily moved by fork lift or pallet jack.

Characteristics, dimensions and operating values are based upon design calculations and performance tests. The information in this technical data sheet may change without notice as the result of additional data or product refinement. Beverly division of CPI should be consulted before using this information for final equipment design.

CABINETS

Several enclosure systems are available. These range from a NEMA 4X (completely sealed enclosure) type to a more conventional 3-bay laboratory 19 inch rack system (shown in picture). The beam (high voltage) power supply may also be remotely mounted from the main enclosure that houses the rest of the system if there is some advantage in doing that. As shown, the standard enclosure system consists of 3 enclosures. Two are 19 inch racks and one is 24 inches to accommodate the IOT and its support cart. The left bay houses the embedded controller, high voltage power supply, and solid state RF power amplifier. The middle bay contains the floating grid deck, IOT magnet power supply and several other lower voltage DC power supplies. The right bay houses the IOT, circulator (if purchased), and output waveguide. Internal air circulating fans move air through air-water heat exchangers located in the partition between the bays when using the NEMX 4X optional enclosure.

WAVEGUIDE SYSTEM

The components in the output waveguide system include a dual-directional coupler and an optical arc detector. Should an arc occur in the waveguide run, the arc detector circuitry will remove the RF drive power to the IOT in less than 10 microseconds after the arc is detected.

The dual-directional coupler provides a calibrated sample of both the RF power generated by the system and the RF power reflected back to the IOT. These samples are fed to the embedded controller where this information is used in process control as well as system protection.

System control will prevent damage to the IOT from the excessive reflected power by reducing or removing the RF drive to it. System control also shuts off the IOT beam power supply for a IOT arc-event.

The WR-650 waveguide is typically brought out through the top, or back-right of the cabinet for the NEMA 4X enclosure option, but custom configurations are available for the waveguide interface point on the enclosure.

For assistance, contact CPI Industrial Microwave Systems Application Engineering with your system requirements.

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